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## APPLICANTS

Masataka Ito, Kanagawa, JAPAN;

SDI \*\* CONTINUING DATA \*\*\*\*\* none

 \*\* FOREIGN APPLICATIONS \*\*\*\*\* SDI  
 JAPAN 068745/2001 03/12/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/04/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Manetta</i> Examiner's Signature	<i>SDI</i> Initials			

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## TITLE

SOI SUBSTRATE, ANNEALING METHOD THEREFOR, SEMICONDUCTOR DEVICE HAVING THE SOI  
 SUBSTRATE, AND METHOD OF MANUFACTURING THE SAME

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